PATENT

Docket No.: LBL-IB-1498-1

Applicant or Patentee: WENBING YUN; JOHN SPENCE; HOWARD A. PADMORE; ALASTAIR A.

MacDOWELL; MALCOLM R. HOWELLS

Serial or Patent No.:

o.: 09/927,428

Filed or Issued:

AUGUST 9, 2001

For:

METHOD FOR NANOMACHINING HIGH ASPECT RATIO STRUCTURES

Group: Examiner:

POWER OF ATTORNEY BY ASSIGNEE AND EXCLUSION OF INVENTOR(S) UNDER 37 C.F.R. 3.71

Dear Sir:

The undersigned assignee of the entire interest in the above-identified subject application hereby appoints

John P. O'Banion, Reg. No. 33,201

as its attorney to prosecute this application and to transact all business in the United States Patent and Trademark Office connected therewith, said appointment to be to the exclusion of the inventors and their attorney(s) in accordance with the provisions of 37 C.F.R. 3.71.

An assignment of the entire interest in the above-identified subject application:

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[X] is submitted herewith for recording.

Please direct all telephone calls to John P. O'Banion at (916) 498-1010 and all correspondence relative to said application to the following address:

John P. O'Banion, Esq. O'BANION & RITCHEY LLP 400 Capitol Mall, Suite 1550 Sacramento, CA 95814

Dated: October 15, 2001

ASSIGNEE: THE REGENTS OF THE UNIVERSITY OF CALIFORNIA

Typed Name: David Aston

Title: Manager, Patent Prosecution

Patent Department

LAWRENCE BERKELEY LABORATORY

One Cyclotron Road, MS 90-1121

Berkeley, CA 94720

Serial No. 69/927,428 AUGSUT 9, 2001 Examiner Group Art Unit 1765 Aution: METHOD FOR NANOMACHINING HIGH ASPECT RATIO STRUCTURES Thereby certify that this Power of Attorney by Assignec (Page 1) (Lidanti) type of correspondence) s being deposited with the United States Postal Service as first class mail in an envelope addressed to: The Assistant Commissioner for Patents, Washington, D.C. 20231 on November 14, 2001 (Date) JOHN E O'BANION (Typed or Printed Master of Ferson Mailing Correspondence) Note: Each paper must have its own certificate of mailing.	plicant(s): WENBIN	MAILING BY FIRST CLA G YUN ET AL.	(1)	LBL-1B-1498-1
hereby certify that this Power of Attorney by Assignee (Page 1) (Identify type of correspondence) s being deposited with the United States Postal Service as first class mail in an envelope addressed to: The Assistant Commissioner for Patents, Washington, D.C. 20231 on November 14, 2001 (Date) 10 INTEO BANION (Typed or Printed Super of Page on Mailing Correspondence) (Signature of Page on Mailing Correspondence)		_	Examiner	3
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Applicant or Patentee: WENBING YUN; JOHN SPENCE; HOWARD A. PADMORE; ALASTAIR A.

MacDOWELL; MALCOLM R. HOWELLS

Serial or Patent No.:

09/927,428

Filed or Issued:

AUGUST 9, 2001

For:

METHOD FOR NANOMACHINING HIGH ASPECT RATIO STRUCTURES

Group: Examiner:

ASSIGNEE CERTIFICATION UNDER 37 C.F.R. 3.73(b)

In accordance with 37 C.F.R. 3.73(b), the assignee hereby certifies that the evidentiary documents with respect to its ownership have been reviewed and that, to the best of the assignee's knowledge and belief, title is in the assignee seeking to take this action.

Dated: October 15, 2001

ASSIGNEE: THE REGENTS OF THE UNIVERSITY OF CALIFORNIA

Signature: 1 mm / Carter

Typed Name: David Aston

Title: Manager, Felent Presecution

Patent Department

LAWRENCE BERKELEY LABORATORY One Cyclotron Road, MS 90-1121

Berkeley, CA 94720

ERTIFICATE OF Noplicant(s): WENBING	AAILING BY FIRST CLASS YUN ET AL.	MAIL (37 CFR 1.8)	Docket No. LBL-IB-1498-1
Serial No. 09/927,428	Filing Date AUGSUT 9, 2001	Examiner	Group Art Unit 1765
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I hereby certify that this	Assignee Certification (Page 1)	(Identify type of correspondence)	,,,,
is being deposited wit	h the United States Postal Service		nvelope addressed to: The
Assistant Commission	er for Patents, Washington, D.C.	20231 on November	
		JOHN P-O'P	ANION
	-	(Typed or Printed Name of Person)	sailing Currespondence)
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	Note: Each paper must hav	e its own certificate of mailing.	
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PATENT

Attorn y Docket No. LBL-IB-1498-1

Applicant:

Sent By: O'BANION & RITCHEY;

WENBING YUN; JOHN SPENCE; HOWARD A. PADMORE; ALASTAIR A.

Mad

MacDOWELL; MALCOLM R. HOWELLS

Serial No.:

09/927,428

Filed:

AUGUST 9, 2001

Title:

METHOD FOR NANOMACHINING HIGH ASPECT RATIO STRUCTURES

Group: Examiner:

BOX ASSIGNMENT

Assistant Commissioner for Patents

Washington, D.C. 20231

ASSIGNMENT (DOCUMENT) COVER LETTER

PATENT OR PATENT APPLICATION

1. NAMES OF PARTY(IES) MAKING TRANSFER

Name 1:

WENBING YUN

Name 2:

JOHN SPENCE

Name 3:

HOWARD A. PADMORE

Name 4:

ALASTAIR A. MacDOWELL

Name 5:

MALCOLM R. HOWELLS

2. IDENTITY OF PARTY(IES) TO WHOM TRANSFER IS MADE

This transfer is being made to:

Name:

THE REGENTS OF THE UNIVERSITY OF CALIFORNIA

Address:

1111 FRANKLIN STREET, 12TH FLOOR

OAKLAND, CA 94607-5200

3. INTENTION OF DOCUMENT

A brief description of what the accompanying document intends to accomplish is that it is an:

X Assignment

_ License

Security Interest

	and	Other	<u> </u>		Sec. or	
4.	IDENT	TIFICATI	ON OF PATEN	T OR APPLICATION	•	
	Partic	ulars of ti	ne patent or app	plication to which the accompa	nying document applies ar	e:
	Invent	or(s):		JN; JOHN SPENCE; HOWARI .; MALCOLM R. HOWELLS	D A. PADMORE; ALASTAI	RA.
	For (ti	tle):	METHOD FO	R NANOMACHINING HIGH A	SPECT RATIO STRUCTU	RES
	(a)	_	•	pplication filed herewith.		
	(b)	<u>X</u>		oplication serial no. <u>09/927,42</u>		<u>001</u> .
	(c)		U.S. patent no	o issued	•	
5.	NAME AND ADDRESS TO WHICH CORRESPONDENCE SHOULD BE MAILED Please address all correspondence and return the recorded document to: John P. O'Banion O'BANION & RITCHEY LLP 400 Capitol Mall, Suite 1550 Sacramento, CA 95814					
6.	NUM	BER OF	APPLICATION	S OR PATENTS IDENTIFIED	AND TOTAL FEE DUE	
	The n	umber o	f applications of	r patents identified herein is:	<u>1</u>	
	Total	Fee Due				\$ 40.00
7.	DATE DOCUMENT WAS EXECUTED					
	The a	accompa	nying document	t was executed on: Octobe	r 10, 2001 <u>.</u>	
8.	FEE PAYMENT					
	fee p	ayment i	is provided for a	as follows:		
	_	New /	Application trans	smittal (Item 18 - INCLUDED I	N FILING FEE)	
	_	FWC	Transmittal (Ite	em VII)		

Transmittal of Filing under 37 CFR 1.60(b) (Item 11)

Attached is a check in the sum of __\$40.00

<u>X</u>

Sent By: O'BANION & RITCHEY;

Nov-19-01 4:02PM;

Page 22/31

	X Charge Account No. <u>07-1137</u> if any additional f e is due.
	Charge Account No in the sum of A duplicate of this transmittal is attached.
9.	STATEMENT OF AUTHENTICITY
	The undersigned certifies that, to the best of his or her knowledge and belief, the information ed in this cover sheet is true and correct, and any copy of the document submitted for recording is opy of the original document.
10.	SIGNATURE
Dated:	
	Annual An

John P. O'Banion, Reg. No. 33,201 O'BANION & RITCHEY LLP 400 Capitol Mall, Suite 1550 Sacramento, CA 95814 (916) 498-1010

Nov-19-01 4:02PM;

PATENT

Attorney Docket No. LBL-IB-1498-1

ASSIGNMENT

For good and valuable consideration, the receipt of which is hereby acknowledged, ASSIGNOR(S),

9164981074;

Name:

WENBING YUN

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BERKELEY, CA 94703

Nationality:

UNITED KINGDOM

Name: Address: MALÇOLM R. HOWELLS 1868 CATALINA AVENUE

BERKELEY, CA 94707

Nationality:

UNITED STATES

hereby sell(s), assign(s) and transfer(s) to ASSIGNEE:

THE REGENTS OF THE UNIVERSITY OF CALIFORNIA, A CALIFORNIA CORPORATION, 111 FRANKLIN STREET, 12th Floor, OAKLAND, CA 94607-5200,

and the successors, assigns and legal representatives of the ASSIGNEE, the entire right, title and interest for the United States and its territorial possessions and in all foreign countries, including all rights to claim priority, in and to any and all improvements which are disclosed in the invention entitled:

METHOD FOR NANOMACHINING HIGH ASPECT RATIO STRUCTURES

and which is found in

- U.S. provisional patent application filed herewith and listing the above named person(s) (a) \mathbf{I} as inventor(s).
- U.S. patent application filed h rewith listing the above named person(s) as inventor(s). (b)

Sent By: O'BANION & RITCHEY;

(c)	[X]	U.S. pat int application seri	al no. <u>09/927,428</u>	_, filed on _	August 9, 2001
(d)	11	U.S. Patent No.:	. issued		

and any legal equivalent thereof in a foreign country, including the right to claim priority and, in and to, all Letters Patent to be obtained for said invention by the above application or any continuation, division, continuation-in-part, extension or substitute thereof, and any reissue, reexamination or extension of said Letters Patent and all rights under all International Conventions for the Protection of Industrial Property;

ASSIGNOR(S) hereby covenant(s) that no assignment, sale, agreement or encumbrance has been or will be made or entered into which would conflict with this assignment;

ASSIGNOR(S) further covenant(s) that ASSIGNEE will, upon its request, be provided promptly with all pertinent facts and documents relating to said Invention and said Letters Patent and legal equivalents as may be known and accessible to ASSIGNOR and will testify as to the same in any interference, litigation, or proceeding relating thereto and will promptly execute and deliver to ASSIGNEE or its legal representative any and all papers, instruments or affidavits required to apply for, obtain, maintain, issue or enforce said application, said invention and said Letters Patent and said equivalents thereof which may be necessary or desirable to carry out the purposes thereof. An attorney of record is authorized and requested by the execution of this assignment to insert into this assignment the filing date and serial number of said application when officially known.

AND the <u>ASSIGNOR(S)</u> request(s) the Commissioner of Patents and Trademarks to issue said Letters Patent of the United States and any reissue or extension thereof to the ASSIGNEE, the Regents of the University of California.

Date:	10/10/01	Inventor:	WENBING YUN
Date:	10/10/01	Inventor:	JOHN SPENCE JOHN SPENCE
Date:	9/14/07	Inventor:	HOWARD A PADMORE
Date:	10/1/01	Inventor:	ALASTAIR A. MacDOWELL
Date:	9/28/01	Inventor:	Mhrveles MALCOLM R. HOWELLS

Docket No. CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8) Applicant(s): WENBING YUN ET AL. LBL-IB-1498-1 Serial No. Filing Date Examiner Group Art Unit 09/927,428 **AUGSUT 9, 2001** 1765 Invention: METHOD FOR NANOMACHINING HIGH ASPECT RATIO STRUCTURES I hereby certify that this Assignment Cover Letter and Assignment (Page 1 thru. 5) (Identify type of correspondence) is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The Assistant Commissioner for Patents, Washington, D.C. 20231 on November 14, 2001 (Typed or Printed Name of Derson Mailing Correspondence) (Signature of Person Mailing Correspondence) Note: Each paper must have its own certificate of mailing.